

Notice of References Cited

Application/Control No.

10/567,015

Applicant(s)/Patent Under
Reexamination
ARIMOTO ET AL.

Examiner

LILIANA CERULLO

Art Unit

2629

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0146893	08-2003	Sawabe, Daiichi	345/89
*	B	US-2004/0046725	03-2004	Lee, Baek-Woon	345/088
*	C	US-2005/0128413	06-2005	Son et al.	349/143
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

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